IFW

Serial No. 10/649285

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PASENT APPLICATION

Mventor(s):

Avinoam Kornblit

Timofei Nikita Kroupenkine

Mary Louise Mandich Tobias Manuel Schneider Joseph Ashley Taylor

Donald Weiss Shu Yang

Case:

18-14-12-2-5-1-16

Serial No.:

10/649285

Filing Date:

August 27, 2003

Examiner:

Group Art Unit:

Title:

Method And Apparatus For Reducing Friction Between A Fluid And

A Body

COMMISSIONER FOR PATENTS

P.O. BOX 1450

ALEXANDRIA, VA 22313-1450

SIR:

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

In accordance with 37 CFR 1.97(b), the enclosed Information Disclosure Statement, with attached reference(s), is submitted for consideration in the above-identified application.

Copies of the listed documents are enclosed together with the search report that listed these documents.

NO FEE IS REQUIRED

In the event of any non-payment or improper payment of a required fee, the Commissioner is authorized to charge or to credit **Lucent Technologies Deposit Account No. 12-2325** as required to correct the error.

110000110119,

David W. Herring, Attorne

Reg. No. 51069 908-582-4326

Date: _____

Docket/Administrator (Room 3J-219)

Lucent Technologies Inc. 101 Crawfords Corner Road Holmdel, NJ 07733-3030

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on June 15, 2004.

Rose E. Ewald



PAMPORMATION DISCLOSURE STATEMENT

Case Name. Serial No. Applicant: Filing Date: Group: Kornblit 18-14-12-2-5-1-16

10/649285 A. Kornblit, et al.

A. Kombili, et al. August 27, 2003

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
	AA	6,185,961	2/13/2001	Tonucci, et al.	65	60.4	1/27/1999
	AB	US Pat. App. 10/798064		Arney, et al			3/11/2004
	AC	US Pat. App. 10/806543		Arney, et al			3/23/2004
	AD	US Pat. App. 10/816569		Gasparyan, et al.			4/1/2004
	AE	US Pat. App. 10/674448		Hodes, et al.			9/30/2003
-	AF	US Pat. App. 10/803565		Hodes, et al.			3/18/2004
	AG	US Pat. App. 10/803641		Hodes, et al.			3/18/2004
	АН	US Pat. App. 10/403159		Kornblit, et al.			3/31/2003
	AI	US Pat. App. 10/649285		Kornblit, et al.			8/27/2003
	AJ	US Pat. App. 10/716084		Kroupenkine, et al.			11/18/2003
	AK	US Pat. App. 10/803576		Kroupenkine, et al.			3/18/2004
·	AL	US Pat. App. 10/810774		Kroupenkine, et al.			3/26/2004

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation

OTHER (including Author, Title, Date, Pertinent Pages, etc.)

AM	Kim, et al., "Nanostructured Surfaces for Dramatic Reduction of Flow Resistance in Droplet-Based Microfluidics," IEEE, pp. 479-482 (2002).

^{***}References listed beyond AZ would list as AA-1, AB-2, AC-3 thru AZ-26.

EXAMINER	DATE CONSIDERED

^{***}Note First Page ONLY Header/Footer. Subsequent pages must ONLY have page # layout as header

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant